Docket No.

267410US26PCT,

IN RE APPLICATION OF: Masanobu IGETA, et al.

SERIAL NO: 10/527,642

FILED:

March 14, 2005

FOR:

METHOD FOR FORMING INSULATING FILM ON SUBSTRATE, METHOD FOR MANUFACTURING

IAP12 Rec'd PCT/PTO 0 3 JUL 2007

JUL 0 3 2007

SEMICONDUCTOR DEVICE AND SUBSTRATE-PROCESSING APPARATUS

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Transmitted herewith is an amendment in the above-identified application.

- No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE		CALCULATIONS
TOTAL	13	MINUS	21	0	х	\$50	=	\$0.00
INDEPENDENT	5	MINUS	4	1	х	\$200	=	\$200.00
APPLICATION SIZE		MINUS	100	0 (each addtl. 50 sheets)	х	\$250	=	\$0.00
	☐ MULTIPLE DEPENDENT CLAIMS + \$360 =					\$0.00		
	TOTAL OF ABOVE CALCULATIONS					\$200.00		
· ·	☐ Reduction by 50% for filing by Small Entity					\$0.00		
						тот	AL	\$200.00

- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

07/09/2007 GFREY1

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